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UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 10/677,007
Applicant: Tingkai Li *et al.*
Filed: September 30, 2003
Group #: 1762
Examiner: Brian K. Talbot

Confirmation Number: 7277

Docket No: SLA.0793
Customer No: 55376
For: MOCVD Selective Deposition of C-axis Oriented $\text{Pb}_5\text{Ge}_3\text{O}_{11}$ Thin Films on In_2O_3 Oxides

MS AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111

**Terminal Disclaimers
Introductory Comments**

In response to the Office Action dated May 8, 2006, please amend the above-identified Application as follows:

Amendment to the Specification None

Amendment to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendment to the Drawings None

Remarks/Arguments begin on page 11 of this paper.

An **Appendix** is not included.